

PATENT Attorney Docket No.: COOL-00800

Examiner:

Group Art Unit: 3753

162 N. Wolfe Road Sunnyvale, CA 94086 (408) 530-9700

Customer No.: 28960

TRANSMITTAL LETTER

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Girish Upadhya et al.

Serial No.: 10/698,180

Filed: October 30, 2003

For: OPTIMAL SPREADER SYSTEM,

DEVICE AND METHOD FOR FLUID COOLED MICRO-SCALED HEAT EXCHANGE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313

Sir:

Enclosed please find an Information Disclosure Statement and Form PTO-1449, including copies of the references contained thereon, for filing in the U.S. Patent and Trademark Office

You will also find enclosed the associated Transmittals, Electronic Information Disclosure Statements, and United States Patent and Trademark Office Acknowledgment Receipts for the electronically filed Information Disclosure Statement (EFS ID #57478); (EFS ID #57479); (EFS ID #57481); and (EFS ID #57483) filed on March 19, 2004.

The Commissioner is hereby authorized to charge any additional fee or credit overpayment to our Deposit Account No. 08-1275. An originally executed duplicate of this transmittal is enclosed for this purpose.

> Respectfully submitted. HAVERSTOCK & OWENS LLP

Dated: 3/19/04

Thomas B. Haverstock Reg. No.: 32,571

Attorneys for Applicants

CERTIFICATE OF MAILING (37 CFR§ 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450

HAVERSTOCK & OWENS LLI



ate: 03/22/2004

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INFORMATION DISCLOSURE STATEMENT

OPTIMAL SPREADER SYSTEM. For: DEVICE AND METHOD FOR FLUID COOLED MICRO-SCALED

HEAT EXCHANGE

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Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313

Sir:

The citations listed below, copies attached, may be material to the examination of the above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

United States Patents or Published Patent Applications have been filed electronically (EFS ID #57478); (EFS ID #57479); (EFS ID #57481); and (EFS ID #57483). Applicants have become aware of the following printed publication which may be material to the examination of this application:

- Chinese Publication No. CN 97212126.9;
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Respectfully submitted,

HAVERSTOCK & OWENS LLP

Dated: 3-19-04

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Attorneys for Applicants

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Attorney Docket No.: COOL-00800

Applicants: Girish Upadhya et al.

Group Art Unit: 3753 Filing Date: October 30, 2003

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OPTIMAL SPREADER SYSTEM, DEVICE AND METHOD FOR FLUID COOLED MICRO-SCALED HEAT Title of Invention EXCHANGE Submission Type: Information Disclosure Statement

Application Number: 10/698180

57478

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First Named Applicant: Girish Upadhya

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OPTIMAL SPREADER SYSTEM, DEVICE AND METHOD FOR FLUID COOLED MICRO-SCALED HEAT EXCHANGE Invention

Application Number: 9903 First Named Applicant: Girish Upadhya

Attorney Docket Number

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